

NLL-Assisted Multilayer Graphene Patterning

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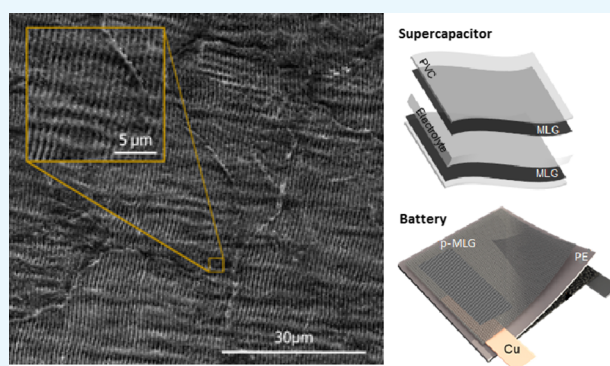
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Supporting Information

ABSTRACT: The range of applications of diverse graphene-based devices could be limited by insufficient surface reactivity, unsatisfied shaping, or null energy gap of graphene. Engineering the graphene structure by laser techniques can adjust the transport properties and the surface area of graphene, providing devices of different nature with a higher capacitance. Additionally, the created periodic potential and appearance of the active external/inner/edge surface centers determine the multifunctionality of the graphene surface and corresponding devices. Here, we report on the first implementation of nonlinear laser lithography (NLL) for multilayer graphene (MLG) structuring, which offers a low-cost, single-step, and high-speed nanofabrication process. The NLL relies on the employment of a high repetition rate femtosecond Yb fiber laser that provides generation of highly reproducible, robust, uniform, and periodic nanostructures over a large surface area ($1 \text{ cm}^2/15 \text{ s}$). NLL allows one to obtain clearly predesigned patterned graphene structures without fabrication tolerances, which are caused by contacting mask contamination, polymer residuals, and direct laser exposure of the graphene layers. We represent regularly patterned MLG (p-MLG) obtained by the chemical vapor deposition method on an NLL-structured Ni foil. We also demonstrate tuning of chemical (wettability) and electro-optical (transmittance and sheet resistance) properties of p-MLG by laser power adjustments. In conclusion, we show the great promise of fabricated devices, namely, supercapacitors, and Li-ion batteries by using NLL-assisted graphene patterning. Our approach demonstrates a new avenue to pattern graphene for multifunctional device engineering in optics, photonics, and bioelectronics.



INTRODUCTION

The patterning and microstructuring of graphene films can selectively enhance certain (opto)electronic capabilities of graphene-based devices and can offer not only new applications but also most importantly multifunctionality of the next generation graphene-based devices for energy storage, photonics, and bioelectronics.^{1–4} Engineering graphene structure restricts the motion of electrons in specific directions, for example, by forming a junction-like structure that changes from a zero-gap conductor to a semiconductor.⁵ Hence, when graphene is patterned into narrow ribbons⁵ or ordered in accordance with the substrate geometry,⁶ we expect the opening of an energy gap and, consequently, tuning of the transport properties of graphene-based devices. Besides, patterning increases the specific surface area of graphene, which resulted in a higher capacity of corresponding devices. The multifunctionality of the graphene surface driven by imposing a super periodic potential⁷ and forming active centers (by defects, oxygen-based functional groups, and self-assembled

monolayers) controls graphene electronic properties consistently. Therefore, patterning of graphene could be a good approach for tuning the transport properties of graphene-based devices and the reactivity by increasing the surface area and artificial ordering of graphene.

Several methods which require execution of different steps for the patterning procedure have been demonstrated. For example, mechanical cleavage,⁸ scanning probe lithography,⁹ photocatalytic etching,¹⁰ plasma etching,¹¹ chemical etching,^{11,12} assembling,¹³ combination of soft-lithography with oxygen plasma etching,^{14,15} and so forth. Although these methods are suitable for large-scale fabrication of a variety of patterns, they involve multiple processes and, therefore, are time consuming and costly. Alternatively, so-called in situ techniques enable the growth of already-patterned structure

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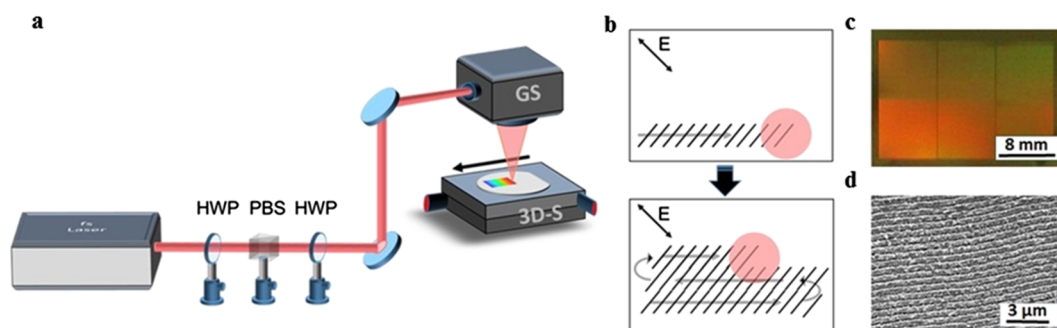


Figure 1. (a) Schematic image of a FS laser system (Yb-doped fiber laser, 1030 nm), galvanometer scanner (GS), motorized 3D translation stage (3D-S), half-wave plate (HWP), and polarization beam splitter (PBS). (b) Scanning direction of the laser beam over the sample. The laser beam spot is represented as a pink circle. The polarization direction is indicated by an *E* vector. (c) Digital photograph and (d) SEM image of the structured Ni foil.

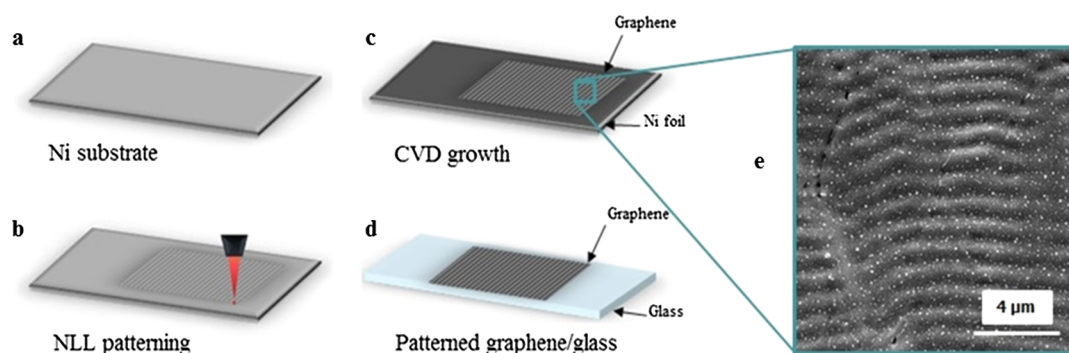


Figure 2. Schematic image of “step-by-step” patterning of graphene. (a) Nickel foil and (b) preliminary-structured nickel foil with NLL technique applying various laser power (380–310 mW). (c) CVD-grown patterned MLG on the structured nickel foil. (d) Patterning of MLG transferred onto the glass. (e) SEM image of the p-MLG.

based on, for example, patterning of catalytic metal films before growth,¹⁶ laser-induced chemical vapor deposition (CVD)¹⁷ and so forth. However, most of the grown materials require to be transferred on a desired substrate that will lead to the generation of surface and edge defects. To prevent disordered carbon–carbon bonds from film defects and to avoid the formation of contaminations (e.g., graphene release with catalyst), direct writing^{18,19} or cutting of already grown graphene^{20,21} has been employed. Among all manufacturing techniques, only nonlinear laser lithography (NLL)²²—a new laser-based technique—is a single-step, high-speed (1 cm²/15 s), highly productive (does not require specified environmental conditions) and, hence, the most efficient method to fabricate small-/large-scale and mask-free micro-/nanopatterns of various nature and symmetries. Since 1965, the fabrication of regular nanostructures²³ on various surfaces (metals,²⁴ semiconductors,²⁵ and glasses²⁶) was realized by laser-induced periodic surface structuring—LIPSS.²⁷ The main challenge is still precise quality control.²⁶ We propose the NLL (improved LIPSS) as a novel solution, which offers highly accurate control of the formation of nanostructures induced by ultrashort pulses. NLL initiates and regulates the metal-oxide nanostructures with unprecedented uniformity because of the positive nonlocal and negative local feedback mechanisms, respectively.²² Most importantly, a significant advantage of the method is an ability to use nonplanar/3D and rough substrate surfaces that are in demand in device engineering. In this study, we report a new approach for multilayer-graphene patterning with the NLL technique for developing high-resolution graphene-based microstructured devices on various substrates.

We experimentally demonstrate the feasibility of predetermined patterning of multilayer graphene (p-MLG) on a nickel substrate by using a high-power femtosecond (FS) Yb fiber laser. Regularly patterned MLG is CVD grown on the surface of preliminarily structured nickel foil, followed by transfer onto the desired substrate for characterization and device testing. The fabricated p-MLG films show high-quality morphology in comparison to the other existing fabrication methods, which is demonstrated by scanning electron microscopy (SEM), water contact angle (WCA) measurement, surface free energy and adhesion calculation, Raman spectroscopy, and Fourier-transform infrared spectroscopy. We manifest electro-optical measurements on p-MLG as well as show the performance of graphene-based devices in supercapacitor and battery constructions. This research provides a new approach for the first patterning of MLG with the NLL technique for developing graphene-based devices.

RESULTS AND DISCUSSION

Line nanostructure formation on MLG is performed through its growth on a prepatterned nickel foil with precisely determined nanostructures on its surface. A schematic of the nanostructuring setup and the principle of the laser beam scanning over the substrate are illustrated in Figure 1a,b, respectively. Detailed characterization of the NLL technique is described in the Method Summary part.

Following the nickel foil surface nanostructuring, the growth of the MLG film is performed (Figure 2). To achieve desirable patterns, an NLL technique with coordinated adjustment of laser power (380–310 mW), a scanning speed of 1000 mm/s,

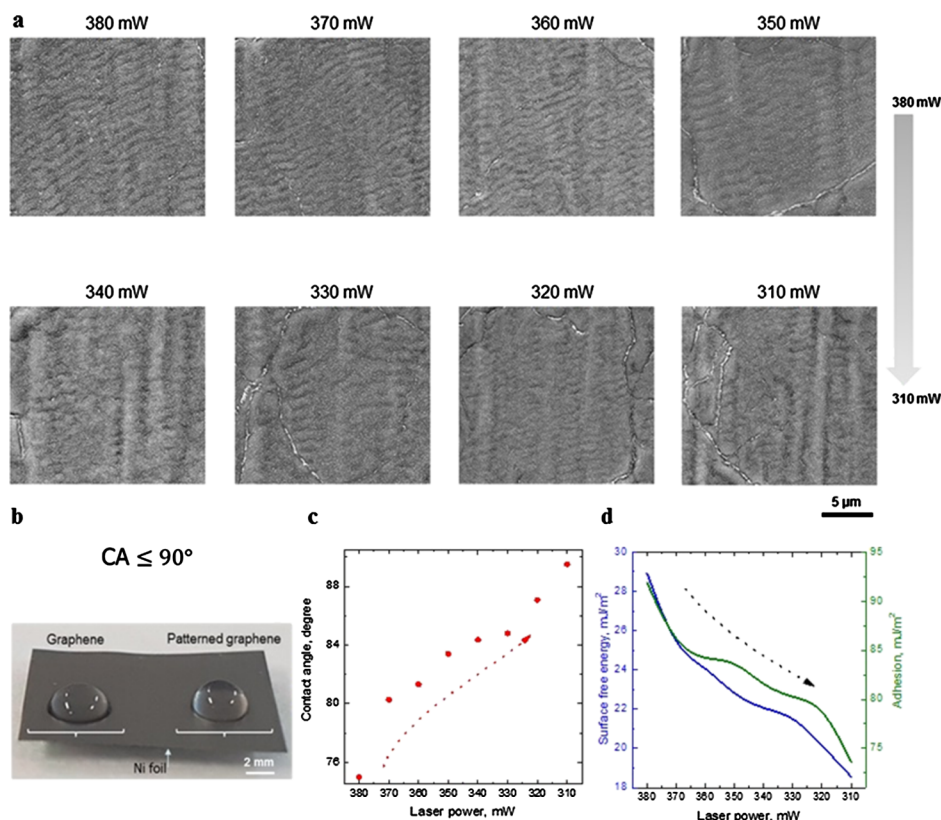


Figure 3. (a) Morphology and surface characteristics of the p-MLG. SEM images of the CVD-synthesized p-MLG on the structured Ni foil by an FS laser power treatment from 380 to 310 mW. The 5 μm scaled images obtained at 30 V, 11 000–14 000 \times magnification. (b) Digital photograph of placing a drop of deionized water (DI) on the surface of the pristine and patterned MLG. (c) WCA (θ) on the patterned MLG surface and (d) adhesion (W_{pw}) and surface free energy (γ_{p}) vs laser power structuring; error is ± 5 units.

and a spot size of 10 μm is provided. We used 50 μm thick structured nickel foil as a catalyst for MLG synthesis in the CVD system. The growth is carried out in the mixture of argon (Ar) and hydrogen (H_2) atmosphere. Methane (CH_4) is a source of carbon which arises from gas decomposition under high temperature. Graphene patterns on the nickel foil are transferred onto polyvinyl chloride (PVC, Sigma, lamination foils) using a lamination technique;²⁸ afterward, nickel is etched in 1 M iron(III) chloride hexahydrate solution (98%, Sigma-Aldrich item #207926).

Figure 3 demonstrates the morphology and surface characteristics of the obtained graphene patterns on the PVC substrate. The depth of the grooves on the MLG surface produced via laser structuring of the Ni catalyst is gradually reduced by decreasing the laser power for every 10 mW (Figure 3a). We observe disordering of the graphene surface and formation of a larger number of grain boundaries and defects. It turns out that the alignment of graphene nanostructures directly depends on the deepness of patterns in the Ni foil, and the resultant graphene pattern serves as a holding lattice.

Tailoring of graphene-surface wettability and understanding its response to different environmental conditions are the major steps toward the development of efficient graphene-based appliances in biosensors.²⁹

To characterize the surface capabilities of graphene patterns, we place a drop of DI on the surface of pristine and patterned MLG (Figure 3b). Obviously, the location of water drops indicates distinctive wettability of graphene zones at a contact angle $\leq 90^\circ$ (Figure 3c). Normally, single-layer graphene is hydrophilic, which means that its WCA is $\leq 90^\circ$ (corresponds

to a high wettability) and the graphene surface is chemically active.³⁰ When we increase the number of graphene layers, the WCA is about $\geq 90^\circ$, which corresponds to low wettability.³¹ It implies that the surface of MLG is hydrophobic and consequently more inert. But in this study, we demonstrate an opposite result—the surface of MLG is hydrophilic. Figure 3c shows the variation of the contact angle as a function of laser power. It is observed that the WCA increases from a value of 75° to 89.52° after the gradual laser treatment of the MLG surface, and this value remains nearly 90° (Figure S1 and Table S1). Although WCA data provide valuable information on the wettability of the p-MLG surface, other surface features—adhesion (W_{pw}) and surface free energy (γ_{p})—are the key parameters characterizing the surface and its interaction with other materials. Besides, these parameters are closely related not only to wettability but also to many other important properties at the surface/interface and friction.³² Therefore, we calculated the adhesion and surface free energy of graphene patterns based on the contact angle data by the Young–Dupre equations:³³ $\gamma_{\text{w}}(1 + \cos \theta_0) = W_{\text{pw}}$ and $\gamma_{\text{p}} = \gamma_{\text{w}}/4(1 + \cos \theta_0)$,² where θ_0 is the contact angle at equilibrium, γ_{w} is the water surface energy (73 mJ/m^2), W_{pw} is the adhesion energy of water to the MLG surface, and γ_{p} is the surface free energy.

Hence, we determined that the surface energy of p-MLG is mutually opposite to the WCA values, and by estimating the data from Table S1, we found the highest and lowest surface energies of the p-MLG samples—28.92 mJ/m^2 (WCA = 75°) and 18.56 mJ/m^2 (89.52°), respectively. Moreover, the surface energy is caused by adhesion forces which are the reason of formation of the surface bonds. Values of surface energy and

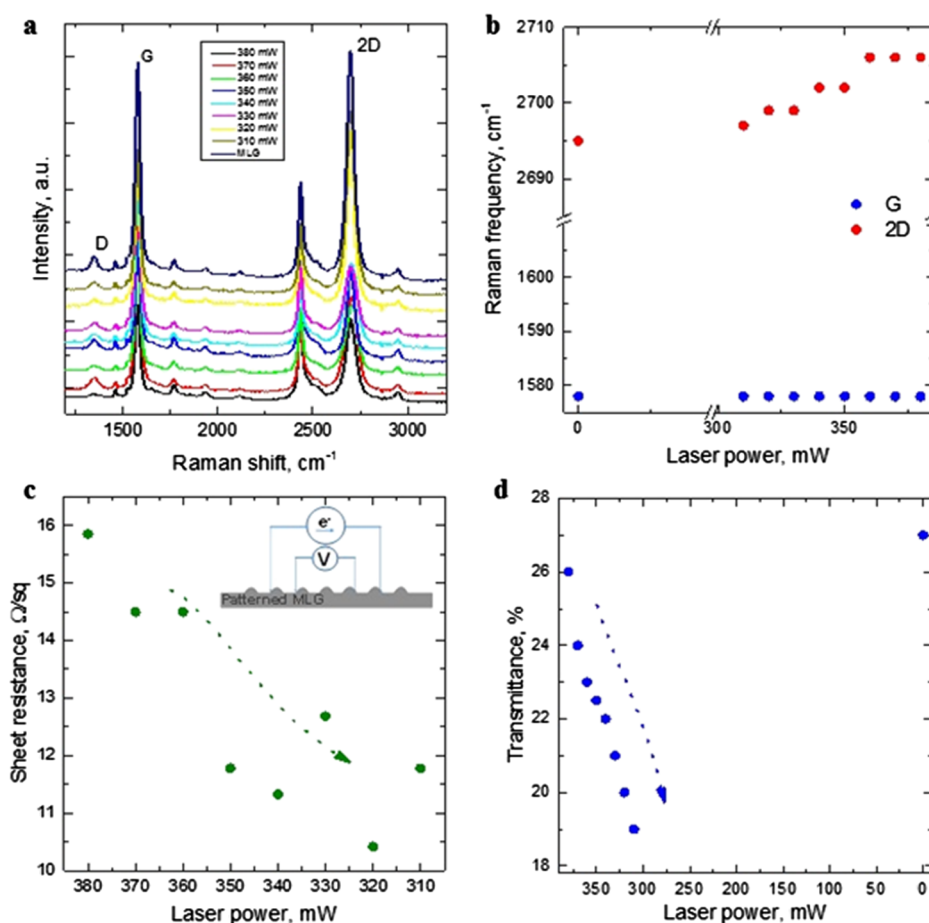


Figure 4. Optical and electrical properties of the p-MLG. (a) General view of Raman spectra (G-, D-, and 2D-peaks) of MLG with different patterns. (b) Variation of Raman frequency as a function of laser power. (c) Variation of the sheet resistance of p-MLG as a function of laser power. The inset shows the schematic representation of the four-point measurement system. (d) Optical transmittance of the p-MLG on the PVC substrate vs laser power.

adhesion are always linearly proportional (Figures 3d, S2, and S3); therefore, a higher surface energy corresponds to a higher adhesion and vice versa. Our results indicate lower surface free energy of all patterned graphene samples compared to the surface free energy of water, which means that water partially wets out the graphene surface. The graphene roughness formed by laser power treatment from 380 to 310 mW determines the increase of the WCA and the surface free energy reduction, in other words, a degradation of the wettability and adhesion. The surface of the graphene produced with 310 mW laser power in comparison with the rest of the samples is more hydrophobic.

To characterize the graphene patterns grown on various structured Ni foils, Raman spectroscopic analysis is performed using a laser excitation of 532 nm (Figure 4a). For single Raman measurements, 20 \times objective and 20 s integration time are used. The collected Raman spectra are the typical profiles of few-layer graphene/MLG. The main G- and 2D-peaks of graphene are clearly observed at around 1578 cm^{-1} (similar for all samples) and 2695–2706 cm^{-1} , respectively. The fixed position of G-peaks (Figure 4b) indicates stability in the planar vibrational mode of the sp^2 -hybridized carbon arrangement and consequently determines the resemblance of graphene nature for all obtained patterns. The negligible 2D band shape differences and its blue shift with decreasing laser power during surface structuring are caused by the decrease of the thickness/number of graphene layers³⁴ (Figure 4b). Analyses of the peak

intensity ratio of the 2D- and G-bands are performed (Table S2 and Figure S4). The $I_{2D/G}$ ratio of these bands for all graphene patterns is equal to or less than “1”, which indicates few/multilayeredness. The appearance of a low-intensity D-band in each case corresponds to the defect formation. Defectiveness stimulated by a laser beam via its contact with the Ni surface is manifested as a fingerprint of the already imperfect structure. Nevertheless, the relatively stable $I_{2D/G}$ ratio in terms of laser power and sharp symmetric 2D-bands is the confirmation for a high-quality patterned few-layer graphene/MLG.

Because the groove depth of the p-MLG gradually decreases, the graphene surface roughness increases, and the surface becomes hydrophobic under laser treatment, the electrical transport property of graphene can be tuned by the surface morphology of the created patterns. Thus, the sheet resistance (Figure 4c) and optical transmittance (Figure 4d) of the p-MLG transferred on a PVC substrate are measured, and this demonstrated that patterning reduces the sheet resistance from 16 to 10 Ω/sq despite the fact that the obtained p-MLG already possesses low sheet resistance (about 20 Ω/sq). Besides, we identified a directly proportional correlation between laser power and the sheet resistance of grown graphene patterns: each reduction in the laser power of pattern processing reduces the sheet resistance of the obtained p-MLG (e.g., 380 mW corresponds to 16 Ω/sq and 310 mW corresponds to 10 Ω/sq).

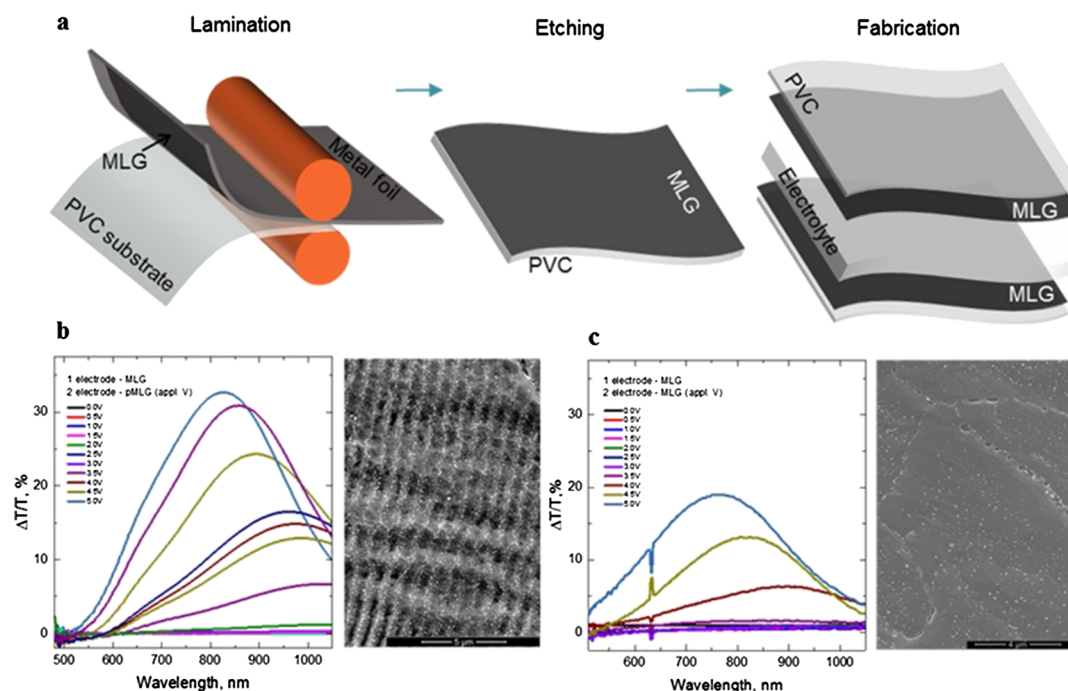


Figure 5. MLG-enabled supercapacitor. (a) Schematic image of supercapacitor preparation: first stage—lamination with PVC at 120 °C, second stage—etching of catalyst with 1 M iron chloride solution, and third stage—device fabrication. Normalized change in the transmission of a supercapacitor with (b) patterned and (c) flat MLG electrodes using an ionic liquid as an electrolyte for bias voltage in the range of 0–5 V.

A variation of optical transmittance of the p-MLG on the PVC substrate at around 800 nm as a function of laser power is shown in Figures 4d, S5, and S6. We observed about 1.5 times enhancement of optical transmittance with an increase of laser power from 310 to 380 mW. It is known that when the number of layers increases, the thickness becomes more uniform and results in a decrease of optical transmittance.³⁵ Apparently, the sheet thickness of the wrinkle configuration changes—decreasing³² with applied lower laser power. It means that thinner and severe wrinklelike ordering of graphene with deeper structuring (380 mW obtained p-MLG) provides enhanced optical transmittance.

On the basis of the detailed morphological and electro-optical investigation of p-MLG samples, structures fabricated under 380 mW are selected. Such a graphene pattern possesses a distinct structure alignment, acting as a holding lattice which prevents defect appearance. It provides low sheet resistance (16 Ω/sq) and higher optical transmittance in comparison with other graphene patterns. Additionally, the thickest 380 mW obtained p-MLG is more hydrophilic compared to other proposed variety of patterns. The hydrophilicity provides reactivity to graphene patterns and impacts its surface area, which will significantly affect the performance of graphene-based devices. Therefore, we employed 380 mW obtained p-MLG for supercapacitor and Li-ion battery designs and compared their performance with respect to the flat graphene-based devices.

We demonstrate the optical features of a graphene-enabled supercapacitor behaving as an optical modulator. Figure 5a shows the schematic image of supercapacitor preparation. The process begins with hot lamination of MLG/p-MLG with PVC followed by etching of nickel in 1 M FeCl₃·H₂O solution. After the transfer-printing process, we attached two graphene-coated PVC substrates using 250 μm thick adhesive frames and affixed two copper wires to apply a voltage to the graphene electrodes

covered with silver-based conductive ink. The created supercapacitor cell was filled with 50 μL of ionic liquid electrolyte [DEME][TFSI] [98.5%, diethyl methyl(2-methoxyethyl)-ammonium bis(trifluoromethyl sulfonyl)imide], Sigma-Aldrich item #727679).

The change of the optical transmittance of a supercapacitor with patterned (Figure 5b) and flat MLG electrodes (Figure 5c) is measured by using a Bruker VERTEX 70v Fourier-transform infrared spectrometer, in which the spectral range is from 500 to 1100 nm. The optical change is performed by applying a voltage in the range of 0–5 V for both devices; the transmission condition is normalized at 0 V, which confirms the stability of supercapacitors. At 0 V, the transmittance is only 1–2% for both devices and slightly varies with the wavelength. On applying 5 V for an MLG-enabled device, the transmittance increases sharply to 19% at 750 nm, whereas on applying 3.5 V for p-MLG-enabled device, the transmittance increases at first to 16% at 950 nm. At 5 V, the supercapacitor based on p-MLG demonstrates the second stage of the transmittance increase—32% at 800 nm.

The observed “2” times increase in the transmittance value of the device with p-MLG compared to that of the MLG-based device indicates the double stepwise electrostatic doping effect on graphene, which happened during intercalation of electrolytes: at first in the thinner part (grooves) and then in the thicker part (wrinkles). As a result, the transmittance enhancement occurs because of the light beam interaction with the patterns where the p-MLG thickness is reduced—grooves part. At this point, the light scattering decreases and light transmission increases accordingly. Therefore, the light throughput of the p-MLG-enabled device will be higher compared to that of the MLG-enabled device.

We also defined high modulation depths³⁶ of about 9 and 6 dB for p-MLG- and MLG-based devices, respectively. Because the variety of optical modulator applications is determined by

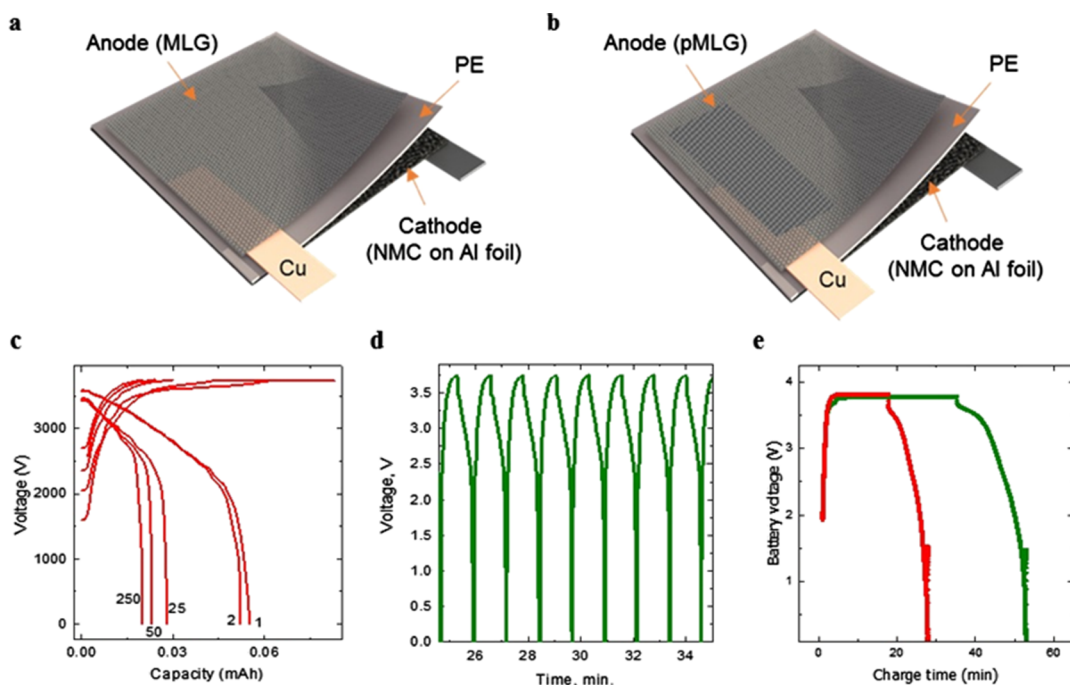


Figure 6. Graphene-enabled Li-ion battery. (a) Schematic image of the symmetrically constructed secondary battery based on the flat and (b) patterned MLG. MLG/p-MLG acted as an electrochromic layer (anode). Lithium nickel manganese cobalt oxide operated as a charge counter electrode (cathode), providing a reversible electrochemical reaction in devices operating in the transmissive/reflective modes. (c) Galvanostatic discharge/charge curves of the MLG-based battery after 1st, 2nd, 25th, 50th, and 250th measurements and (d) its life cycle as a function of time. (e) Voltage profiles for the constant current charge and discharge of Li-ion batteries incorporating MLG (green curve) and p-MLG (red curve) as negative electrodes. The optical change results from an electric current of ≈ 3 mA at low dc potentials.

the high modulation depth (>7 dB, as high-rate interconnects and high-sensitivity sensing) and is limited when the modulation depth is less than ~ 4 dB (as passive mode-locking and short-distance data transmission),³⁷ it is crucial to acquire the modulation depth increase. Our results indicate broader applicability for p-MLG-enabled devices and their capability to operate in the visible range as far as we are able to increase the modulation depth index by 1.5 times.

Figure 6 represents a graphene-enabled battery structured as a typical Li-ion battery. This device posturizes a single-cell battery, where the electrodes are sandwiched symmetrically (Figure 6a,b). As an anode, we placed MLG/p-MLG on the polymer substrate, which acted as an electrochromic layer as well. To make good contact, we set a copper frame attached to the graphene electrode. Lithium nickel manganese cobalt oxide (known in battery manufacturing as an NMC, Litarion) is operated as a charge counter electrode—cathode—providing a reversible electrochemical reaction. Finally, the electrodes are separated using a $20\ \mu\text{m}$ thick porous polyethylene membrane (PE, 42% porosity, Targray) soaked with 1 M lithium hexafluorophosphate solution in ethylene carbonate and ethyl methyl carbonate (Sigma-Aldrich item #746738).

We measured the capacitance of the MLG-enabled Li-ion battery approximately 250 times, demonstrating negligible decrease of its value with each next charging/discharging cycle (Figure 6c). Inherently, all batteries gradually discharge eventually whether they are used or not. This capacity loss is typically caused by slow parasitic reactions occurring within the battery. The life cycle is the key for the good performance of a battery, and thus, increasing the life cycle is one of the first parameters that should be focused on when aiming at providing efficiency of Li-ion batteries. Usually, heteroatom doping,

chemical impregnating, and hybridization of graphene electrodes are the best approaches to improve the prolongation of Li-ion batteries. For example, a graphene hybrid-based battery can yield 400 discharge/charge cycles with 0.01% capacity loss per cycle.³⁸ A battery in which the graphene electrode is impregnated with sulfur demonstrates ultralong viability (2000 cycles and 0.028% capacity decay per cycle).³⁹ In our case, the proposed battery with pure MLG demonstrated operation for 1000 cycles (Figure 6d), which together with the assessed capacity (0.01% capacity loss per cycle) demonstrates promising results.

On the other hand, the internal charge/discharge efficiency plays a key role as well because slow discharging and fast charging designed in a way to reduce the impact of self-heating is required. To analyze the battery performance, the voltage dependence of charging/discharging processes by applying constant current (3 mA) for both devices is provided (Figure 6e). We observed productivity reduction in the p-MLG-based battery when compared to the MLG-based battery because of a decrease of the charge/discharge time by approximately “2” times. This allows us to predetermine the viability of the p-MLG-enabled Li-ion battery during 500 cycles. The reduction in the number of life cycles is due to the change in the graphene surface area after the patterning procedure. In fact, the patterns are artificially ordered defects that make graphene structure more loosened and promote faster intercalation/deintercalation of Li-ions. Therefore, the presented approach could lead to new bifunctional applications combining the properties of energy storage and electrically switchable devices.

CONCLUSIONS

In conclusion, we demonstrate a novel NLL technique for the patterning of MLG via Ni catalyst substrate prestructuring. NLL provides contamination-free pattern replications into varying geometrical shapes and sizes with a possibility to transfer p-MLG on the diverse substrates. The regulation of hydrophobic/hydrophilic properties of graphene by various laser power adjustments is shown. The control of hydrophobic/hydrophilic properties defines the multifunctionality of graphene-enabled devices due to the graphene surface (dis-)ordering and, consequently, the formation of reactive oxygen-based functional groups. The distinct graphene structure alignment (which prevents defect appearance) assisted by the strongest laser power (380 mW) contributes to certain p-MLG electro-optical changes (sheet resistance decrease and optical transmittance enhancement). The p-MLG ability to operate as an electrically reconfigurable medium for supercapacitor and Li-ion battery designs are represented. The p-MLG-based supercapacitor testing results reveal 2 times transmittance value increase (in comparison with the MLG-based supercapacitor) caused by light interaction with patterned structures where its thickness is reduced. The p-MLG-based battery indicates long-life viability (500 charging/discharging cycles) with 0.01% capacity loss per cycle; the negative feedback leading toward twice the device productivity reduction which occurred due to graphene structure loosening after patterning and, consequently, (de)intercalation process accelerating. We anticipate the NLL-based p-MLG to be a new approach to overcome the limitations imposed by the existing postsynthesis processes which will open a wide applicability gateway for advanced graphene-based devices in energy storage, wearable electronics, and biosensors.

METHOD SUMMARY

Nonlinear Laser Lithography. The nanostructuring setup consists of a FS laser system, GS, and motorized 3D-S (Figure 1). The FS system is a home-made Yb-doped fiber laser (1030 nm) which was reported before.⁴⁰ It involves a dispersion-managed oscillator, a fiber stretcher, several amplification stages and a grating compressor. The stretcher fiber was distributed between the amplifier stages to provide the optimal pulse peak power during amplification to balance between the gain-narrowing and the self-phase modulation. The laser can produce up to 1 μ J of pulse energy at a repetition rate of 1 MHz, which corresponds to 1 W of average power. The minimal pulse duration which can be obtained from the system is 100 fs. Because the output light of the laser is linearly polarized, the HWP placed between the laser and the polarization beam splitter provides control of the laser power on the sample. The second HWP allows the control of polarization on a sample. The sample was placed on the motorized 3D stage in the focal plane of the GS f-theta lens.

The laser beam was scanned over the nickel surface in the way that during every line scan it was partially overlapped with the already created structure. In this way we preserved the concept of nonlinear laser lithography,²² which allows coherent extension of the created structure over a large area surface, thus, improving the quality of the structure. The maximum scanning area for our model of GS is 1 \times 1 cm². To extend the area, XY translation stage was used. With the given pulse energy and repetition rate, the processing speed in our work was as fast as 15 s for 1 \times 1 cm² area. It can be increased in the future by

scaling the repetition rate of the laser by keeping the pulse energy constant, that is, simultaneously scaling the average power.

CVD Growth of Multilayer Graphene. A CVD system was used for the growth of MLG. The growth process was carried out under ambient pressure in a 3" quartz tube furnace, using 50 μ m thick Ni foil. Argon gas was flushed into the quartz tube for at least 5 min to remove oxygen. Afterward, hydrogen was supplied while argon continued to run (ratio of Ar/H₂ is about 100/100 sccm). The gas-filled CVD system was left for heating till the temperature is raised to 1000 $^{\circ}$ C. Once 1000 $^{\circ}$ C temperature was reached, the methane flow is established at 30 sccm together with the Ar/H₂ flow at 100/100 sccm, followed by a waiting time of 5 min. In the end, the CH₄ flow is turned off and the system is cooled down to room temperature in \sim 1 h while keeping the Ar/H₂ flow environment at 100/100 sccm.

Transfer Printing of Multilayer Graphene. The following steps are needed for the analysis of the MLG/p-MLG surface and fabrication of graphene-enabled devices after CVD growth on a Ni foil. First, one side of the graphene-covered Ni foil was protected by paper, whereas the other side was in contact with PVC. Second, the patch of paper/graphene/Ni/graphene/PVC was sent through a lamination machine with a temperature of about 120 $^{\circ}$ C. The obtained PVC/graphene/Ni samples were then dipped in a 1 M FeCl₂ aqueous etching solution for a few hours. After the nickel was etched, the PVC/graphene membranes were placed in DI for a few hours and rinsed as well. Then, the samples were blow-dried with N₂ gas and were ready to use.

Characterization Methods. WCA of the MLG/p-MLG on PVC substrate was obtained using a home-made contact angle measurement setup. The setup consists of the following elements: a white LED, XYZ translation stage with standard micrometers (Thorlabs), video camera (Thorlabs, DCC1645C-USB 2.0 CMOS camera, 1280 \times 1024, color sensor), and usual medical syringe with a 200 μ m diameter needle. We put a DI water droplet of 4 μ L on the investigated graphene surface and took digital photographs. We measured the contact angles using a program Screen Protractor which allows us to easily and quickly measure any angle on the screen to the nearest degree. The morphological analyses of the investigated graphene samples were performed using scanning electron microscopy (Nova NanoSEM 600). To determine the graphitization fingerprint and compare the defectiveness of MLG and p-MLG surfaces, a Jobin Yvon HORIBA Raman microscope system with 20 \times microscope objectives and 20 s integration time was used. The excitation wavelength was 532 nm. The transmittance measurements in the wavelength range between 450 and 1100 nm were performed by using a Bruker VERTEX 70v Fourier-transform infrared spectrometer integrated with a Si photodiode. The sheet resistance measurements were carried out at four probe station platforms with the support of a Keithley 2600 multimeter. MLG was attached on the patterned area to make Ohmic contact with the four electrodes. Then, sheet resistance was calculated using the standard formula ($R_s = \pi R / \ln 2 \approx 4.53R$).

Device Performance Characterization. *Graphene-Enabled Supercapacitors.* Optical measurements were performed in the 450–1100 nm wavelength range by a Bruker VERTEX 70v Fourier-transform infrared spectrometer equipped with a Si photodiode. Transmittance, $T_p(\lambda)$, spectra were recorded by graphene-based supercapacitors biased using the Keithley 2400 Source measure unit.

Graphene-Enabled Li-Ion Battery. The voltage and time readings of charging/discharging processes were generated using the Keithley 2600 Source Meter instrument. The data were collected under a constant current of 3 mA and processed with LabVIEW software.

■ ASSOCIATED CONTENT

● Supporting Information

The Supporting Information is available free of charge on the ACS Publications website at DOI: 10.1021/acsomega.7b01853.

Surface characteristics of patterned MLG; Raman characterization; and optical characterization (Figures S5 and S6) (PDF)

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Notes

The authors declare no competing financial interest.

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